

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/600,770	WU, SHENSHEN	
Examiner	Art Unit	
David Buttner	1712	

SEARCHED					
Class	Subclass	Date	Examiner		
528	49 ,	12/20/2004	DB		
528	54	12/20/2004	DB		
528	55	12/20/2004	DB		
528	58	12/20/2004	DB		
528	61	12/20/2004	DB		
528	65	12/20/2004	DB		
528	66	12/20/2004	DB		
528	76	12/20/2004	DB		
528	80	12/20/2004	DB		
528	83	12/20/2004	DB		

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
west	12/20/2004	DB	
east	12/20/2004	DB	
chem ab	12/20/2004	DB	